



DOCKET NO: VSEA 18-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Donald W. Berrian et al.
Serial No: 09/990,848
Confirmation No: 2772
Filed: November 21, 2001
For: HYBRID SCANNING SYSTEM AND METHODS FOR ION
IMPLANTATION
Examiner: Johnnie L. Smith
Art Unit: 2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 28 day of January, 2004.

Mark Superko

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition for Extension of Time

A two-month extension of time to January 28, 2004 is requested for response to the Examiner's Communication of October 28, 2003.

The extension fee of \$420.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,
Donald W. Berrian et al. , Applicants

By:

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